AMENDMENTS TO THE CLAIMS

1. (Previously Presented) A capacitance type sensor comprising:

a detective member configured to detect an external force applied thereto;

a first electrode facing the detective member,

a second electrode disposed between the detective member and the first electrode such that a capacitance element is formed by the first electrode and the second electrode, the second electrode being displaceable in a direction of displacement of the detective member when the detective member is displaced, and

a flexible board on which the first electrode and the second electrode are disposed, the flexible board being folded such that the first electrode and the second electrode face each other,

wherein the capacitance type sensor identifies the displacement of the detective member on the basis of a detection, using a signal input to the first electrode, of a change in capacitance of the capacitance element caused by a change in distance between the first electrode and the second electrode.

2. (Previously Presented) The capacitance type sensor according to claim 1, wherein the first electrode and the second electrode are both disposed on one side of the flexible board.

3. (Currently Amended) The capacitance type sensor according to claim[[s]] 1, which further comprises:

a substrate mounting the flexible board thereon; and

a supporting member disposed on the flexible board and configured to support the detective member.

4. (Previously Presented) The capacitance type sensor according to claim 3, wherein a specified space is defined between the second electrode and the supporting member.

5. (Previously Presented) The capacitance type sensor according to claim 1, further comprising:

a third electrode disposed on the flexible board;

a reference electrode disposed on the flexible board and having a predetermined electrical potential; and

a fourth electrode electrically connecting the reference electrode and configured in a spaced relation to the third electrode, wherein the fourth electrode contacts with the third electrode by elastic deformation thereof based on the displacement of the detective member.

6. (Previously Presented) The capacitance type sensor according to claim 5, wherein the detective member comprises separate members corresponding to the second electrode and the fourth electrode, respectively.

7. (Previously Presented) A capacitance type sensor comprising:

a substrate;

a flexible board mounted on the substrate, wherein a first electrode is disposed on a first portion of the flexible board and a second electrode is disposed on a second portion of the flexible board, and the first electrode and the second electrode face each other by folding the flexible board;

a supporting member disposed on the substrate; and

a detective member configured to be supported by the supporting member and displaceable by a force applied from outside, wherein displacement of the detective member causes the second electrode to be displaced.

8. (Currently Amended) The capacitance type sensor according to claim 7 ~~5~~, further comprisinges a resin film covering the first electrode and the second electrode but not covering the central area of the second electrode, wherein an surface of the resin film on the first potion contacts another surface of the resin sheet on the second portion in a state that the flexible board is folded.